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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Jc551 U.S. PTO  
09/228148  
01/11/99

In re Application of: Yasunori INOUE

Serial No.: (Division of 08/806,425)

Group Art Unit: 2814

Filed: January 11, 1999

For: SEMICONDUCTOR DEVICE INCLUDING AN INSULATION FILM ON  
A CONDUCTIVE LAYER AND MANUFACTURING METHOD THEREOF

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)**

Assistant Commissioner for Patents  
Washington, D.C. 20231

January 11, 1999

Sir:

^ The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449.

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were made of record in parent application Serial No. 08/806,425. Accordingly, copies of the references are not attached.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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